IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplicant(s): MAMITSU et al.

Serial No.: 10/699,838

Filed: November 4, 2003

Title: SEMICONDUCTOR DEVICE

HAVING RADIATION

STRUCTURE

Atty. Dkt.: 01-103-CON4

Group Art Unit: 2822

Examiner: POTTER, ROY KARL

Allowed: April 12, 2004 Confirmation No. 5579

Date: July 6, 2004

Commissioner for Patents Arlington, VA 22202 Mail Stop Issue Fee

REQUEST FOR RETURN OF INITIALED FORM PTO-1449

Sir:

Pursuant to MPEP §609, Applicant hereby respectfully requests that the Examiner initial the enclosed copy of the Form PTO-1449, originally submitted concurrently with the filing of the present application, in the appropriate place in the left-hand column as proof that the listed references have been considered and made of record. Applicant further requests that the Examiner return a copy of the initialed form to the undersigned at his earliest convenience.

Respectfully submitted,

Dames E. Barlow Reg. No. 32,377

JEB/moa Posz & Bethards, PLC 11250 Roger Bacon Drive Suite 10 Reston, VA 20190 (703) 707-9110 Customer No. 23400



					Page 1 of 4
FORM PTO-1449	ATTY. DKT NO.	1-103-CON4	SER. NO.	10/699,838	
	APPLICANT	MAMITSU et al.			
	FILING DATE	Nov. 4, 2003	GROUP	2822	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	5,708,299	Jan. 13, 1998	Teramae et al		
	6,072,240	June 6, 2000	Kimura et al		
	5,248,853	Sep. 28, 1993	Ishikawa et al		
	5,801,445	Sep. 1, 1998	Ishihara et al		
	5,229,646	Jul. 20, 1993	Tsumura		
	4,558,345	Dec. 10, 1985	Dwyer et al		1
	4,546,374	Oct. 8, 1985	Olsen et al		
	4,984,061	Jan. 8, 1991	Matsumoto		
	5,481,137	Jan 2, 1996	Harada et al.		
	4,827,082	May 2, 1989	Horiuchi et al		
	4,538,170	Aug. 27, 1985	Yerman		

FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO
	EP0660396	12/24/93	Europe					
	EP0450980	4/05/91	Europe					
	6-291223	10/94	JAPAN					, ,
	3-20067	01/91	JAPAN				: 1.	
	2146174	11/85	GB					

	Takamura, "Electronic Technology", pp. 56-59 (1999-5).
	Johnson et al., "Silicon Precipitate Nodule-Induced Failures of MOSFETS", ISTFA '91 (Nov. 11-15, 1991), pp. 161-165.
	:
EXAMINER	DATE CONSIDERED

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PATENT APPLICATION

					Page 2 01 4
FORM PTO-1449	ATTY. DKT NO.	1-103-CON4	SER. NO.	10/699,838	
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	FILING DATE	Nov. 04, 2003	GROUP	2822	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DATE		NAME	CLASS	SUB CLASS
	4,646,129	Feb. 24, 1987	Yerman et al		
	4,141,030	Feb. 20, 1979	Eisele et al		
	6,448,645	Sep. 10, 2002	Kimura		
	6,538,308	Mar. 25, 2003	Nakase		
	6,380,622	Apr. 30, 2002	Hirai		
	09/675,209	Filed Sept. 29, 2000	Suzuki		
	5,221,851	Jun. 22, 1993	Gobrecht et al.		

FOREIGN PATENT DOCUMENTS

TRANSLATION

DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO
4-249353	9/92	JAPAN					
11-260979	09/99	JAPAN					
4-27145	01/92	JAPAN					
9-148492	06/97	JAPAN				-	
4-12555	01/92	JAPAN					
4-103150	04/92	JAPAN					
60-137042	07/85	JAPAN					
5-109919	04/93	JAPAN					
61-166051	07/86	JAPAN					
2-117157	05/90	JAPAN					
63-102326	05/88	JAPAN					

EXAMINER	DATE CONSIDERED

PATENT APPLICATION

Page 3 of 4

FORM PTO-1449	ATTY. DKT NO.	1-103-CON4	SER. NO.	10/699,838	1 age 3 01 4
	APPLICANT	MAMITSU et al.			
	FILING DATE	Nov. 04, 2003	GROUP	2822	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE NAME		CLASS	SUB CLASS
	5,990,550	Nov. 23, 1999	Umezawa		
	5,608,610	Mar. 4, 1997	Brzezinski		
	5,396,403	Mar. 7, 1995	Patel		
	5,293,301	Mar. 8, 1994	Tanaka et al.		
	5,641,997	June 24, 1997	Ohta et al.		
	5,789,820	Aug. 4, 1998	Yamashita		

FOREIGN PATENT DOCUMENTS

TRANSLATION

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		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO
		60-235430	11/85	JAPAN					
		07-240432	9/95	JAPAN					
		8-45874	2/96	JAPAN					
		60-95947	05/85	JAPAN					1
		61-265849	11/86	JAPAN					
		62-141751	06/87	JAPAN	,				1
		63-096946	04/88	JAPAN					1
		62-92349	4/87	JAPAN					
		62-287649	12/87	JAPAN					
		59-38734	09/84	JAPAN				-	
		01-228138	09/89	JAPAN					
		54-40569	03/79	JAPAN					
		61-251043	11/86	JAPAN					
		54-95183	07/79	JAPAN					

EXAMINER	DATE CONSIDERED

PATENT APPLICATION Page 4 of 4

FORM PTO-1449	ATTY. DKT NO.	1-103-CON4	SER. NO.	10/699,838	rage 4 01 4
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	2002/0158333	Oct. 31, 2002	Teshima			
	S/N 10/201556	July 24, 2002	Hirano et al.			
	5726466	March 10, 1998	Nishitani			
	4,470,063	Sep. 4, 1984	Arakawa et al.			
	5,708,299	Jan. 13, 1998	Teramae et al			

FOREIGN PATENT DOCUMENTS

TRANSLATION

					INANSLATION		
DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO
59-031042	02/84	JAPAN					
07-038013	02/95	JAPAN					
07-273276	10/95	JAPAN					
08-191145	07/96	JAPAN					
2000-91485	03/00	JAPAN					
W098/12748	3/26/98	PCT					
JP-A-5-283562 *	10/29/93	JAPAN				Х	
JP-A-6-349987 *	12/22/94	JAPAN				X	
JP-A-7-45765 *	2/14/95	JAPAN		`		Х	
JP-A-11-186469 *	7/9/99	JAPAN				Х	
JP-A-2000-31351 *	1/28/00	JAPAN				Х	
JP-A-2001-118961 *	4/27/01	JAPAN				Х	

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